Freeform Search

Database:
US Pre-Grant Publication Full-Text Database
US Patents Full-Text Database
US OCR Full-Text Database
EPO Abstracts Database
JPO Abstracts Database
Derwent World Patents Index
IBM Technical Disclosure Bulletins

Term:
wo-9915933-$.did.

Display: 10 Documents in **Display Format:** - **Starting with Number** 1

Generate: ○ **Hit List** ⦿ **Hit Count** ○ **Side by Side** ○ **Image**

| Search | Clear | Interrupt |

Search History

DATE: Thursday, October 14, 2004 Printable Copy Create Case

Set Name side by side	Query	Hit Count	Set Name result set
	DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=OR		
L35	wo-9915933-$.did.	2	L35
L34	L33 not l32	66	L34
L33	L31 and @ad<20000828	68	L33
L32	L29 and @ad<20000828	2	L32
L31	l30 and l9	136	L31
L30	(l15 or l20) and ((contact$4 or ("near" near2 field) or sil or (immersion near5 Lens$4)) with (expos$6 or exposing or irradiat$6 or mask$1 or photomask$1 or light))	1815	L30
L29	L28 and l9	16	L29
L28	(l15 or l20) same ((contact$4 or ("near" near2 field) or sil or (immersion near5 Lens$4)) with (expos$6 or exposing or irradiat$6 or mask$1 or photomask$1 or light))	326	L28
L27	L26 and @ad<20000828	2	L27
L26	L25 and l9	15	L26
L25	(l15 or l20) same ((contact$4 or ("near" near2 field) or sil or (immersion near5 Lens$4)) with (exposure or exposed or exposing or irraidat$6 or	293	L25

mask$1 or photomask$1))

L24	us-6497996-$.did. or us-6344367-$.did.	4	L24
L23	L22 and @ad<20000828	18	L23
L22	L21 and l9	33	L22
L21	L20 same l11	370	L21
L20	L19 near5 (resist$1 or photoresist$1)	3488	L20
L19	((two or dual or double) adj3 (level$4 or layer$4))	432599	L19
L18	L17 and @ad<20000828	22	L18
L17	L16 and l9	44	L17
L16	L15 same l11	549	L16
L15	L8 near5 (resist$1 or photoresist$1)	4981	L15
L14	L13 and @ad<20000828	146	L14
L13	L12 and l9	301	L13
L12	L11 same l8	48604	L12
L11	(grating$1 or comb or stripe$4 or lines or periodic)	5956826	L11
L10	L9 same l8	105	L10
L9	((L6 or l4 or l2) near8 (thick or thickness$4)) with (resist$1 or photoresist$1)	4136	L9
L8	(multilevel$4 or multilayer$4 or bilayer$1 or bilevel$1 or dilevel$4 or dilayer$4 or ((bi or di or multi or multiple) adj3 (level$4 or layer$4)))	439964	L8
L7	(L6 near8 (thick or thickness$4)) with l1	19	L7
L6	((0.1 or 0.0$1) adj3 (micron$1 or mum or .mu$4))	67694	L6
L5	(L4 near8 (thick or thickness$4)) with l1	238	L5
L4	((1000 or 9$2 or 8$2 or 7$2 or 6$2 or 5$2 or 4$2) adj3 (angstrom or ang or .ang$4))	111892	L4
L3	(L2 near8 (thick or thickness$4)) with l1	292	L3
L2	((100 or 9$1 or 8$1 or 7$1 or 6$1 or 5$1 or 4$1) adj3 nm)	147302	L2
L1	((upper or top or topmost or second or first) near5 (resist$1 or photoresist$1))	72577	L1

END OF SEARCH HISTORY